

Electronic Patent Application Fee Transmittal

Application Number:	10783242			
Filing Date:	19-Feb-2004			
Title of Invention:	ATOMIC LAYER DEPOSITION METHOD OF FORMING AN OXIDE COMPRISING LAYER ON A SUBSTRATE			
First Named Inventor/Applicant Name:	Garo J. Derderian			
Filer:	Paul Steven Holdaway/Susan Wenzl			
Attorney Docket Number:	MI22-2403			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Certificate of correction	1811	1	100	100
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				100